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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/768,556	01/25/2001	Yukihiro Inoue	L8462.01101	5136	
759					
STEVENS, DAVIS, MILLER & MOSHER, L.L.P. Suite 850 1615 L Street, N.W.			EXAMINER		
			GEBREMARIAM, SAMUEL A		
Washington, DC					
			ART UNIT	PAPER NUMBER	
			2811		

Please find below and/or attached an Office communication concerning this application or proceeding.

			Application No.	Applicant(s)	1/m
					24,-
Offic		Action Summary	09/768,556 INOUE, YUKIHIRO		
, ,		,	Examiner	Art Unit	
<u> </u>	The MAII	LING DATE of this communication app	Samuel A Gebremariam	th the correspondence and	
Peri df	r Reply	ente Dave di une dominamedation app	cars on ar cover sneet wi	ur the correspondence add	ress
THE   - External control contr	MAILING I nsions of time r SIX (6) MONTI period for reply period for repl re to reply withi reply received b	O STATUTORY PERIOD FOR REPLY DATE OF THIS COMMUNICATION. may be available under the provisions of 37 CFR 1.1 HS from the mailing date of this communication. It is specified above is less than thirty (30) days, a reply is specified above, the maximum statutory period with the set or extended period for reply will, by statute by the Office later than three months after the mailing adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a re y within the statutory minimum of thirt vill apply and will expire SIX (6) MON . cause the application to become AB	eply be timely filed  y (30) days will be considered timely. THS from the mailing date of this com	munication.
1)[🛛	Respons	ive to communication(s) filed on 08.	lanuary 2003 .		
2a) <u></u>			is action is non-final.		
3)		s application is in condition for allowa		ters, prosecution as to the	merits is
Dispositi	closed in on of Clai	accordance with the practice under	Ex parte Quayle, 1935 C.[	D. 11, 453 O.G. 213.	
		5 <u>-8 and 11-14</u> is/are pending in the a	polication		
		above claim(s) is/are withdray			
ł.		is/are allowed.	vir irom consideration.		
		i-8 and 11-14 is/are rejected.			
		is/are objected to.			
		are subject to restriction and/or	s election requirement		
1	on Papers		election requirement.		
9) 🗌 🧵	The specific	cation is objected to by the Examine	•		
10) 🔲 🗆	The drawing	g(s) filed on is/are: a)□ accep	ted or b) objected to by th	e Examiner.	
		may not request that any objection to the	· · · · · · · · · · · · · · · · · · ·		
11) 🔲 🏾	The propos	ed drawing correction filed on	is: a)  approved b)  di	sapproved by the Examiner.	
	If approve	d, corrected drawings are required in rep	ly to this Office action.		
12) 🔲 🏾	The oath or	declaration is objected to by the Exa	aminer.		
Priority u	nder 35 U.	.S.C. §§ 119 and 120			
13)	Acknowled	lgment is made of a claim for foreign	priority under 35 U.S.C. §	119(a)-(d) or (f).	
a)[	☐All b)☐	Some * c) ☐ None of:			
	1. Cert	ified copies of the priority documents	have been received.		
	2. Cert	ified copies of the priority documents	have been received in Ap	plication No	
	á	ies of the certified copies of the priori application from the International Bur shed detailed Office action for a list of	eau (PCT Rule 17.2(a)).		age
		ched detailed Office action for a list of the detailed of a claim for domestic	•		
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		anslation of the foreign language prov ment is made of a claim for domestion			
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2) Notice	of Draftspers	es Cited (PTO-892) son's Patent Drawing Review (PTO-948) ure Statement(s) (PTO-1449) Paper No(s)	5) Notice of In	ummary (PTO-413) Paper No(s). formal Patent Application (PTO-1	
J.S. Patent and Tra PTO-326 (Rev		Office Act	ion Summary	Part of Pa	per No. 15

Art Unit: 2811

#### **DETAILED ACTION**

## Claim R jections - 35 USC § 112

1. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 13 and 14 recite the limitation "the plan view" in the claims. There is insufficient antecedent basis for this limitation in the claims. Furthermore the plan view is part of the figure description not an invention.

Claims 11 and 12 recite the limitation "said source diffusion layer and said drain diffusion layer" in the claims. There is insufficient antecedent basis for this limitation in the claims.

### Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 14 and 6 are rejected under 35 U.S.C. 102(b) as being anticipated by Pfiester US patent No. 4,918,510.

Pfiester teaches (fig. 3) a semiconductor device comprising: a source side offset diffusion layer region (44) and a drain side offset: diffusion layer region (42) of a second conductivity type in a transistor formed, so as to be separated from each other, in a predetermined region in a region of a first conductivity type in a semiconductor substrate (36); a gate insulator film (48) region formed between the source side offset

Art Unit: 2811

diffusion layer region (44) and the drain side offset diffusion layer region (42); a gate electrode (46) formed on the gate insulator film region, and a diffusion layer (40) of the first conductivity type of which the impurity concentration is higher than that of the region of the first conductivity type and which is formed so as to surround the source side offset diffusion layer region (44), the drain side offset diffusion layer region (42) and the gate insulator film region, wherein both ends of the gate insulator film region, in the channel width direction, form protruding portions (54) that, protrude at the borders of the source side offset diffusion layer region and of the drain side offset diffusion layer region in the direction toward the diffusion layer of the first conductivity type, and wherein the diffusion layer of the first conductivity type is formed so as to surround the protruding portions and so as to be separated from the protruding portions by a predetermined distance.

Regarding claim 6, Pfiester teaches (fig. 3) the entire claimed structure of claim 14 above including the diffusion layer (40) of the first conductivity type is a channel stopper region.

# Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 13 and 5, are rejected under 35 U.S.C. 103(a) as being unpatentable over Pfiester in view of Nagatomo et al. US Patent No. 5,164,806.

Art Unit: 2811

Regarding claim 13 Pfiester teaches substantially the entire claimed structure of claim 14 above including the diffusion layer of the first conductivity type is formed so as not to be substantially present below the gate insulator film region.

Pfiester does not teach the diffusion layer is formed so as to be in contact with the protruding portions.

Nagatomo teaches (fig. 4) forming region (15) between region (5a) and channel stop layer (8) for forming MOS transistor. The formation of region (15) increases the breakdown voltage of the junction.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate the impurity region taught by Nagatomo in the structure of Pfiester in order to increase breakdown voltage. The modified structure of Pfiester would have the diffusion layer contacting the protruding portion.

Regarding claim 5, Pfiester teaches substantially (fig. 3) the entire claimed structure of claim 13 above including the diffusion layer (40) of the first conductivity type is a channel stopper region.

Claims 11, 12, 7 and 8 in so far in compliance of 35 U.S.C. 112 and as best understood by the examiner are rejected under 35 U.S.C. 103(a) as being unpatentable over Pfiester, Nagatomo in view of Murakami US patent No. 4,819,045.

Regarding claims 11 and 12, Pfiester teaches substantially (fig. 3) the entire claimed structure of claims 13 and 14 above including the source side offset diffusion layer and the drain side offset diffusion layer are lower in impurity concentration than diffusion layer.

Art Unit: 2811

Pfiester fails to teach the transistor is a high voltage transistor.

The use of MOS transistors for high voltage application is conventional and also Murakami teaches the use MOS transistor for high voltage application.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the structure of Pfiester for high voltage application as taught by Murakami for improved withstand of high voltage application.

Regarding claims 7 and 8, Pfiester teaches substantially (fig. 3) the entire claimed structure of claims 13 and 14 above including the diffusion layer of the first conductivity type is a channel stopper region (40).

### Response to Arguments

4. Applicant's arguments with respect to claims 9-12 and 5-8 have been considered but are most in view of the new ground(s) of rejection.

#### Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. References C and D are cited as being related to a semiconductor device.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel Admassu Gebremariam whose telephone number is 703 305 1913. The examiner can normally be reached on 8:00am-4: 30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (703) 305-7646. The fax phone numbers

Art Unit: 2811

for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Samuel Admassu Gebremariam January 26, 2003

TOM THOMAS
SUPERVISORY PROTERT EXAMINER
TECHNOLOGY CENTER 2800